



AF/2800

PATENT
Attorney Docket No.: SAM-0298IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Jae-Hak Kim, et al.

Serial No.: 09/994,508

Filing Date: November 27, 2001

Title: METHOD OF FABRICATING SEMICONDUCTOR DEVICES HAVING LOW
DIELECTRIC INTERLAYER INSULATION LAYER

Examiner: Rao, S.

Group Art Unit: 2814

RECEIVED
DEC 13 2002
1C 2800 MAIL ROOMCERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail on the date indicated below in an envelope addressed to BOX AF, Assistant Commissioner for Patents, Washington, DC 20231.

12-6-02

Date


Amy Green

BOX AF

Assistant Commissioner for Patents

Washington, D.C. 20231

TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following listed items:

1. Amendment Transmittal;
2. Amendment after Final Rejection in response to Office Action mailed on September 26, 2002; and
3. Return Postcard

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

Date:

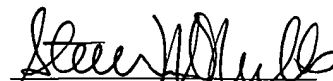
12/6/02
Mills & Onello LLP

Eleven Beacon Street, Suite 605

Boston, MA 02108

Telephone: (617) 994-4900

Facsimile: (617) 742-7774



Steven M. Mills

Registration Number 36,610

Attorney for Applicants